

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q79867

Nobuyuki ETO, et al.

Appln. No.: 10/777,680

Group Art Unit: 1791

Confirmation No.: 5870

Examiner: Jason L. LAZORCIK

Filed: February 13, 2004

For: METHOD OF PROCESSING A GLASS SUBSTRATE FOR A MAGNETIC DISK AND  
METHOD OF MANUFACTURING THE GLASS SUBSTRATE

**PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of one month(s), extending the time for responding to the Office Action of November 24, 2009 to March 24, 2010.

The statutory fee of \$130.00 is being charged to Deposit Account No. 19-4880 via EFS Payment Screen. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

Respectfully submitted,

*/Alan J. Kasper/*

SUGHRUE MION, PLLC  
Telephone: (202) 293-7060  
Facsimile: (202) 293-7860

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Alan J. Kasper  
Registration No. 25,426

WASHINGTON OFFICE

**23373**

CUSTOMER NUMBER

Date: March 23, 2010